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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/719,759	11/20/2003	Chin-Ta Su	MXICP012	3129	
25920 75	0 05/23/2006		EXAMINER		
MARTINE PENILLA & GENCARELLA, LLP 710 LAKEWAY DRIVE			MCDONALD, RO	MCDONALD, RODNEY GLENN	
SUITE 200			ART UNIT	PAPER NUMBER	
SUNNYVALE,	SUNNYVALE, CA 94085				
			DATE MAILED: 05/23/2006	5	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)
	10/719,759	SU, CHIN-TA
Office Action Summary	Examiner	Art Unit
	Rodney G. McDonald	1753
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING D - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailin earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 136(a). In no event, however, may a reply be to will apply and will expire SIX (6) MONTHS from the cause the application to become ABANDON	N. imely filed in the mailing date of this communication. ED (35 U.S.C. § 133).
Status		
Responsive to communication(s) filed on <u>09 №</u> This action is FINAL . 2b) This Since this application is in condition for alloware closed in accordance with the practice under №	s action is non-final. nce except for formal matters, pr	
Disposition of Claims		
4) ☐ Claim(s) 1-17 is/are pending in the application 4a) Of the above claim(s) is/are withdra 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-17 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or	wn from consideration.	
Application Papers		
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) accomposed and applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Example 11.	epted or b) objected to by the drawing(s) be held in abeyance. So tion is required if the drawing(s) is old	ee 37 CFR 1.85(a). bjected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureau * See the attached detailed Office action for a list	ts have been received. Is have been received in Applicativity documents have been received in Rule 17.2(a)).	tion No red in this National Stage
Attachment(s)		
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summar Paper No(s)/Mail D 5) Notice of Informal 6) Other:	

DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-4, 7-10 and 13-15 are rejected under 35 U.S.C. 102(b) as being anticipated by Giewont et al. (U.S. Pat. 6,388,327).

Regarding claims 1, 7, 8, 13, Giewont et al. teach a conventional process for formation of a cobalt silicide comprising providing a substrate having a silicon layer thereon. Precleaning the substrate. Depositing a cobalt layer thereon. Depositing a TiN capping layer on the cobalt. The conventional capping layer is not truly stoichiometric but includes additional nitrogen. (i.e. Nitrogen greater than 1 thus the TiN layer has x atoms of nitrogen for each atom of titanium greater than 0.9). The structure is first annealed in the range of 480 to 570 degrees C. Since the capping layer includes additional nitrogen, nitrogen will diffuse into and through the cobalt layer 2 during the first anneal. During the first anneal the Co diffuses into the silicon to form a layer of CoSi 12. Also the a nonreacted Co layer 22 is formed. The TiN layer and the unreacted Cobalt layer is removed leaving a layer of CoSi. A second anneal can then be carried out to form a layer of CoSi₂ in the range of 690 to 750 degrees C. The CoSi₂ is inherently decreased in resistance. (Column 1 lines 23-41; Column 2 lines 1-16; Column 28-51)

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Regarding claim 2, the second thermal process is performed after removing the non-reactive cobalt layer. (Column 2 lines 47-50)

Regarding claims 3, 9, 14, the TiN layer is formed by a sputtering process. (Column 1 lines 35-37)

Regarding claims 4, 10, 15, the gas used in the sputtering process is N_2 and Ar. (Column 1 lines 35-41)

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 5, 11 and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Giewont et al. (U.S. Pat. 6,388,327).

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Giewont et al. is discussed above and all is as applies above. (See Giewont et al. discussed above)

The difference not yet discussed is the ratio of the nitrogen to argon gas.

Giewont et al. teach that t form a titanium nitride film with excess nitrogen one should operate in region III. (See Fig. 2) The nitrogen flow can be increased above 60 sccm to achieve applicant's gas ratio. (See Fig. 2)

The motivation for operating with a N_2 to Ar ratio of 3:1 is that it allow formation of a film that has excess nitrogen. (Column 2 lines 29-31)

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized a ratio of 3:1 as taught by Giewont et al. because it allows formation of a film with excess nitrogen.

Claims 6, 12 and 17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Giewont et al. (U.S. Pat. 6,388,327) in view of Besser et al. (U.S. Pat. 5,970,370).

Giewont et al. is discussed above and all is as applies above. (See Giewont et al. discussed above)

The difference between Giewont et al. and the present claims is the thickness of the TiN layer.

Regarding claims 6, 12, 17, the thickness of the TiN layer can be 100 Angstroms. (Column 5 lines 48-51)

The motivation for utilizing a particular thickness of the TiN layer is that it allows for formation of a cobalt silicide structure. (See Abstract)

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Therefore, it would have been obvious to one of ordinary skill at the time the invention was made to have modified Giewont et al. by utilizing a particular thickness of the TiN layer as taught by Besser et al. because it allows for formation of a cobalt silicide structure.

Response to Arguments

Applicant's arguments filed March 9, 2005 have been fully considered but they are not persuasive.

In response to the argument that Besser et al. do not teach diffusing nitrogen into the layer of cobalt salicide, it is argued that Giewont et al. suggest the diffusion of nitrogen into the cobalt salicide layer. Giewont et al. recognizes that this occurs in the conventional process and sets forth the conventional process embodiment which shows diffusion of nitrogen into the cobalt. The conventional embodiment of Giewont et al. reads on Applicant's claims. While Giewont et al. discloses that this is undesirable Giewont et al. does teach Applicant's process. (See Giewont et al. discussed above)

In response to the argument that Giewont et al. is not combinable because it is undesirable to introduce nitrogen into the cobalt salicide, while Giewont et al. suggest that it is undesirable to introduce nitrogen it is argued that Giewont et al. do disclose the process as required by Applicant's claims. (See Giewont et al. discussed above)

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP

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§ 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Rodney G. McDonald whose telephone number is 571-272-1340. The examiner can normally be reached on M- Th with Every other Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam X. Nguyen can be reached on 571-272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

> Rodney G. McDonald **Primary Examiner**

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RM May 17, 2006